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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: :
Christopher L. Wooten, et al. : Group Art Unit: 2623
Appl. No.: 09/976,739 : Examiner: Wesley J. Tucker
Filed: October 11, 2001 :

Title: METHOD FOR EVALUATING ANOMALIES IN A SEMICONDUCTOR
MANUFACTURING PROCESS

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION TRANSMITTAL

1. Transmitted herewith is a Response for this application.
2. The fee for claims has been calculated as follows:

CLAIMS AS AMENDED									
	Claims After <u>Amendment</u>		No. Prev. <u>Paid For</u>		Present <u>Extra</u>		<u>Rate - Small</u>		Add'l <u>Fee</u>
Total	20	-	20	=	0	x	\$50.00	=	0.00
Indep.	3	-	3	=	0	x	\$200.00	=	0.00
Filing Fee Calculation:									<u>\$0.00</u>

3. The total fees to be paid are as follows and are enclosed payable to the
Commissioner of Patents and Trademarks:

Fee for claims adjustment: 0.00
Extension fee: 0.00
Total Fees Due: \$0.00

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Amendment Transmittal

4. Applicant believes there are no additional fees required for these filings. The Commissioner is hereby authorized to charge any deficiency to Deposit Account No. 50-2173. A duplicate copy of this Transmittal Letter is enclosed.

Respectfully submitted,

Dated: 30 July 2005 By Rennie William Dover
Rennie William Dover, Reg. No. 36,503
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CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this document (and any as referred to as being attached or enclosed) is being deposited with sufficient postage as first class mail with the United States Postal Service on July 30, 2005 and addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

Rennie William Dover



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Madam/Sir:

In response to the Office action mailed June 7, 2005, please amend the application
as follows: